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10797664 - GAU: 2851

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TUDE	- CIID	DI EI	ACNITA I	Application Number	10/797,664	
THIRD SUPPLEMENTAL				Filing Date	March 11, 2004	
	INFORMATION DISCLOSURE STATEMENT BY APPLICANT			First Named Inventor	Pieter Van GROOS	
STAT				Art Unit	2851	
	(Use as n	nany she	ets as necessary)	Examiner Name	KIM, Peter B.	
Sheet	1	of	1	Attorney Docket Number	1857.7540002	

	U.S. PATENT DOCUMENTS					
Examiner Cite Initials No.1	Cite	Document Number Number-Kind Code ^{2 (If Known)}	Publication Date MM-DD-YYYY	Name of Patentee or	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
	No.'			Applicant of Cited Document		
	US1					
	US2					
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	US20					

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where	
		Country Code ³ Number ⁴ Kind Code ³ (if known)			Relevant Passages or Relevant Figures Appear	
/P.K./	FP1	JP 10-116760 A	05-06-1998	Nippon Kogaku KK		
	FP2					
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	FP6					
	FP7					L
	FP8					
	FP9					

Examiner Signature	/Peter Kim/	Date Considered	09/12/2008	
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TUIDD SUDDI EMENTAL	Application Number	10/797,664		
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STATEMENT BY APPLICANT	Art Unit	2851		
(Use as many sheets as necessary)	Examiner Name	KIM, Peter B.		
Sheet 1 of 1	Attorney Docket Number	1857.7540002		

		NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*					
	NPL1	Office Action for Chinese Application No. 2004100326869 issued April 4, 2008, 12 pgs.			
	NPL2	Peter van Zant, Microchip Fabrication: A Practical Guide to Semiconductor Processing, Third Edition, McGraw Hill Publishing Co., 1997 (the whole book).			
	NPL3				
	NPL4				
	NPL5	·			
	NPL6				
	NPL7				
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	NPL9				
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